



Attorney Docket No. 249/437

EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Dong-wook KIM, et al.

Art Unit: 2881

Serial No. 10/795,979

Examiner: Anthony G. QUASH

Filed: March 10, 2004

Confirmation No. 2293

For: ELECTRON BEAM LITHOGRAPHY APPARATUS
USING A PATTERNED Emitter AND METHOD OF
FABRICATING THE PATTERNED Emitter

STATUS INQUIRY

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Kindly advise the applicant by return mail as to the current status of the captioned application and the date on which the next Action on the merits may be expected.

Respectfully submitted,

December 6, 2005

Date

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